

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Jeong-kwan LEE, et al.

Application No.: 09/982,086

ATTENTION

Confirmation No.: 6758

CERTIFICATE OF CORRECTION

Filed: October 19, 2001

BRANCH

U.S. Patent No.: 7,294,863

Issued: November 13, 2007

For: MICRO-LENS BUILT-IN VERTICAL CAVITY SURFACE EMITTING LASER

**REQUEST FOR CERTIFICATE OF CORRECTION**

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

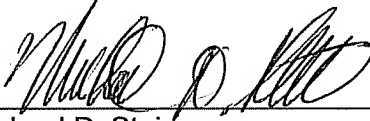
Patentee(s) respectfully request(s) that a Certificate of Correction be issued in the subject patent, pursuant to 35 U.S.C. §254 and 37 C.F.R. §1.322, to correct the mistake(s) shown on the attached Certificate of Correction form.

Since the mistakes are Patent Office mistakes, it is believed that no fee is required.

Respectfully submitted,

STEIN, MCEWEN & BUI, LLP

Date: 11/23/07

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UNITED STATES PATENT AND TRADEMARK OFFICE

CERTIFICATE OF CORRECTION

PATENT NO : 7,294,863

DATED : November 13, 2007

INVENTOR(S) : Jeong-kwan LEE, et al.

Column 13, line 6, insert --;-- after "micro-lens".

Column 19, line 19, change "  $n1 / S1 = n2 / S2 = (n2 - n1) / R$  " to  
--  $n1 / S1 + n2 / S2 = (n2 - n1) / R$  --.

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PATENT NO. 7,294,863

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